

TITLE OF THE INVENTION

Composite Substrate and EL Device Using the Same

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**CROSS-REFERENCE TO RELATED APPLICATION**

This application claims priority to International Application No. PCT/JP01/00813 filed February 06, 2001 and Japanese Application Nos. 2000-029465 filed February 07, 10 2000, 2000-059521 filed March 03, 2000 and 2000-059522 filed March 03, 2000, and the entire content of both applications is hereby incorporated by reference.

**BACKGROUND OF THE INVENTION**

15 **Field of the Invention**

This invention relates to a composite substrate having a dielectric and an electrode, and an electroluminescent (EL) device using the same.

20 **Background Art**

The phenomenon that a material emits light upon application of an electric field is known as electroluminescence (EL). Devices utilizing this phenomenon are on commercial use as backlight in liquid 25 crystal displays (LCD) and watches.

The EL devices include dispersion type devices of the structure that a dispersion of a powder phosphor in an organic material or enamel is sandwiched between electrodes, and thin-film type devices in which a thin-film 30 phosphor sandwiched between two electrodes and two insulating thin films is formed on an electrically insulating substrate. For each type, the drive modes include DC voltage drive mode and AC voltage drive mode. The dispersion type EL devices are known from the past and 35 have the advantage of easy manufacture, but their use is limited because of a low luminance and a short lifetime.

On the other hand, the thin-film type EL devices have markedly spread the practical range of EL device application by virtue of a high luminance and a long lifetime.

5        In prior art thin-film type EL devices, the predominant structure is such that blue sheet glass customarily used in liquid crystal displays and plasma display panels (PDP) is employed as the substrate, a transparent electrode of ITO or the like is used as the  
10      electrode in contact with the substrate, and the phosphor emits light which exits from the substrate side. Among phosphor materials, Mn-doped ZnS which emits yellowish orange light has been often used from the standpoints of ease of deposition and light emitting characteristics. The  
15      use of phosphor materials which emit light in the primaries of red, green and blue is essential to manufacture color displays. Engineers continued research on candidate phosphor materials such as Ce-doped SrS and Tm-doped ZnS for blue light emission, Sm-doped ZnS and Eu-doped CaS for  
20      red light emission, and Tb-doped ZnS and Ce-doped CaS for green light emission. However, problems of emission luminance, luminous efficiency and color purity remain outstanding until now, and none of these materials have reached the practical level.

25       High-temperature film deposition and high-temperature heat treatment following deposition are known to be promising as means for solving these problems. When such a process is employed, use of blue sheet glass as the substrate is unacceptable from the standpoint of heat  
30      resistance. Quartz substrates having heat resistance are under consideration, but they are not adequate in such applications requiring a large surface area as in displays because the quartz substrates are very expensive.

35       It was recently reported that a device was developed using an electrically insulating ceramic substrate as the substrate and a thick-film dielectric instead of a thin-

film insulator under the phosphor, as disclosed in JP-A 7-50197 and JP-B 7-44072.

FIG. 2 illustrates the basic structure of this device. The EL device in FIG. 2 is structured such that a lower electrode 12, a thick-film dielectric layer 13, a light emitting layer 14, a thin-film insulating layer 15 and an upper electrode 16 are successively formed on a substrate 11 of ceramic or similar material. Since the light emitted by the phosphor exits from the upper side of the EL structure opposite to the substrate as opposed to the prior art structure, the upper electrode is a transparent electrode.

In this device, the thick-film dielectric has a thickness of several tens of microns which is about several hundred to several thousand times the thickness of the thin-film insulator. This offers advantages including a minimized chance of breakdown caused by pinholes or the like, high reliability, and high manufacturing yields.

Use of the thick dielectric invites a drop of the voltage applied to the phosphor layer, which is overcome by using a high-permittivity material as the dielectric layer. Use of the ceramic substrate and the thick-film dielectric permits a higher temperature for heat treatment. As a result, it becomes possible to deposit a light emitting material having good luminescent characteristics, which was impossible in the prior art because of the presence of crystal defects.

Preferred conditions for the dielectric material used as the thick-film dielectric include high permittivity, insulation resistance, and dielectric strength. When the substrate material is widespread crystallized glass or  $\text{Al}_2\text{O}_3$ , and the dielectric material is  $\text{BaTiO}_3$ , which is widely used as capacitor material because of good dielectric characteristics, there arises a problem that cracks develop in the  $\text{BaTiO}_3$  dielectric layer upon firing. Since the dielectric layer has a reduced dielectric strength due to

such cracks, an EL device fabricated using this composite substrate is likely to break down. The cause is presumably the difference in coefficient of thermal expansion between the substrate material and the dielectric, which has a  
5 significant influence since the dielectric must be fired at high temperatures. Because of this problem and the need to minimize the reaction of the dielectric material with the substrate material, lead-base dielectric materials having a relatively low firing temperature have been under  
10 predominant consideration as the dielectric material, as disclosed in JP-A 7-50197 and JP-B 7-44072.

However, the use of harmful lead in the raw material is undesirable from the manufacturing standpoint and because the cost of waste recovery is increased. Still  
15 worse, lead-base dielectric materials generally have a lower firing temperature than BaTiO<sub>3</sub>, which prevents the heat treating temperature of a phosphor layer from being elevated, so that EL devices using them fail to provide satisfactory luminescent characteristics.

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#### SUMMARY OF THE INVENTION

An object of the invention is to provide a composite substrate which suppresses reaction of a substrate with a dielectric layer that can otherwise cause degradation of  
25 the dielectric layer and which can be sintered at high temperature while minimizing the generation of cracks in the dielectric layer, as well as an EL device using the same.

The above object is attained by the following  
30 construction.

(1) A composite substrate in which an electrode and a dielectric layer are successively formed on an electrically insulating substrate,

said substrate having a coefficient of thermal  
35 expansion of 10 to 20 ppm/K.

(2) The composite substrate of (1) wherein said

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substrate is composed mainly of magnesia ( $MgO$ ), steatite ( $MgO \cdot SiO_2$ ) or forsterite ( $2MgO \cdot SiO_2$ ).

(3) The composite substrate of (1) or (2) wherein said dielectric layer is a sintered ceramic body composed 5 mainly of barium titanate ( $BaTiO_3$ ).

(4) The composite substrate of (3) wherein said dielectric layer contains one or more oxides selected from the group consisting of manganese oxide ( $MnO$ ), magnesium oxide ( $MgO$ ), tungsten oxide ( $WO_3$ ), calcium oxide ( $CaO$ ), 10 zirconium oxide ( $ZrO_2$ ), niobium oxide ( $Nb_2O_5$ ) and cobalt oxide ( $Co_2O_3$ ).

(5) The composite substrate of (3) or (4) wherein said dielectric layer contains the oxides of one or more elements selected from the group consisting of rare earth 15 elements Sc, Y, La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm, Yb and Lu.

(6) The composite substrate of any one of (3) to (5) wherein said dielectric layer contains a vitreous component composed of silicon oxide ( $SiO_2$ ).

20 (7) An EL device comprising at least a light emitting layer and a second electrode on the composite substrate of any one of (1) to (6).

(8) The EL device of (7) further comprising a second insulator layer between the light emitting layer and the 25 second electrode.

#### FUNCTION

Since the specific substrate material and the dielectric material of the specific composition are used 30 according to the invention, there is fabricated a composite substrate which can be sintered at a high temperature without incurring reaction of the dielectric layer with the substrate that can otherwise cause degradation of the dielectric layer and which has a thick-film dielectric 35 layer free of cracks.

When an EL device is fabricated using the composite

substrate having such a high firing temperature, the heat treating temperature of a phosphor layer can be increased whereby crystal defects in the phosphor layer are reduced and improved luminescent characteristics are obtainable.

5 This function is effective especially when a Ce-doped SrS phosphor layer capable of emitting blue light is deposited. The dielectric layer has a high dielectric strength due to the absence of cracks, allowing high voltage drive ensuring improved luminescent characteristics.

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#### BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a schematic cross-sectional view showing the construction of an exemplary EL device according to the invention.

15 FIG. 2 is a schematic cross-sectional view showing the construction of a prior art EL device.

#### BEST MODE FOR CARRYING OUT THE INVENTION

The composite substrate of the invention has the construction that an electrode and a dielectric layer are successively formed on an electrically insulating substrate. The substrate has a coefficient of thermal expansion of 10 to 20 ppm/K and is preferably composed mainly of magnesia ( $MgO$ ), steatite ( $MgO \cdot SiO_2$ ) or forsterite ( $2MgO \cdot SiO_2$ ).

Also preferably, the dielectric layer is a sintered ceramic body composed mainly of barium titanate ( $BaTiO_3$ ). The dielectric layer may further contain one or more oxides selected from among rare earth oxides,  $MnO$ ,  $MgO$ ,  $WO_3$ ,  $SiO_2$ ,  $CaO$ ,  $ZrO_2$ ,  $Nb_2O_5$  and  $Co_2O_3$ .

30 FIG. 1 is a cross-sectional view of an electroluminescent (EL) device using a composite substrate according to the invention. The composite substrate is a ceramic laminate structure having a substrate 1 of the above-described composition, a thick-film electrode (or first electrode) 2 formed thereon in a predetermined

pattern, and a dielectric layer (or first dielectric layer) 3 of sintered high-permittivity ceramic body formed thereon by a thick-film technique.

The EL device using the composite substrate has a  
5 basic structure as shown in FIG. 1, for example, including  
a thin-film light emitting layer (or phosphor layer) 4, a  
thin-film insulating layer (or second insulating layer) 5,  
and a transparent electrode (or second electrode) 6, which  
are formed on the dielectric layer of the composite  
10 substrate by such a technique as vacuum evaporation,  
sputtering or CVD. A single insulating structure with the  
thin-film insulating layer omitted is also acceptable.

The composite substrate and the EL device using the  
same according to the invention are characterized by the  
15 use as the substrate material of magnesia ( $MgO$ ), steatite  
( $MgO \cdot SiO_2$ ) or forsterite ( $2MgO \cdot SiO_2$ ) which does not react  
with  $BaTiO_3$  of the dielectric layer up to high temperature  
and has a substantially equal coefficient of thermal  
expansion to that of  $BaTiO_3$ . Since the dielectric layer  
20 does not react with the substrate up to high temperature,  
the EL device fabricated using the composite substrate of  
the invention allows the light emitting layer (phosphor  
layer) to be heat treated at a higher temperature, leading  
to improved luminescent characteristics. Also, since the  
25 substrate and the dielectric layer have a substantially  
equal coefficient of thermal expansion, no cracks form in  
the dielectric layer, which has a higher dielectric  
strength. Then the EL device fabricated using the  
composite substrate allows high voltage drive ensuring  
30 improved luminescent characteristics.

The substrate material used is composed mainly of  
magnesia ( $MgO$ ), steatite ( $MgO \cdot SiO_2$ ) or forsterite  
( $2MgO \cdot SiO_2$ ). Any of these materials may be used although a  
35 substrate material having a substantially equal coefficient  
of thermal expansion to that of the dielectric material is  
preferable. Among others, magnesia is preferred.

The substrate formed of such material preferably has a coefficient of thermal expansion of 10 to 20 ppm/K, and especially about 12 to 18 ppm/K.

The lower electrode layer serving as the first 5 electrode is formed at least on the insulated substrate side or within the insulating layer. The electrode layer which is exposed to high temperature during formation of the insulating layer or during heat treatment together with the light emitting layer may be a commonly used metallic 10 electrode composed mainly of palladium, rhodium, iridium, rhenium, ruthenium, platinum, silver, gold, tantalum, nickel, chromium or titanium.

When Pd, Pt, Au, Ag or an alloy thereof is used, firing in air is possible. When BaTiO<sub>3</sub> which has been 15 tailored to be resistant to chemical reduction is used so that firing in a reducing atmosphere is possible, a base metal such as Ni may be used as the internal electrode.

The upper electrode layer serving as the second 20 electrode may be a transparent electrode which is transmissive to light in the predetermined emission wavelength region. In this embodiment, it is especially preferred to use a transparent electrode of ZnO or ITO. ITO generally contains In<sub>2</sub>O<sub>3</sub> and SnO in the stoichiometric composition although the O content may somewhat deviate 25 therefrom. The mixing proportion of SnO<sub>2</sub> to In<sub>2</sub>O<sub>3</sub> is preferably 1 to 20% by weight, and more preferably 5 to 12% by weight. For IZO, the mixing proportion of ZnO to In<sub>2</sub>O<sub>3</sub> is about 12 to 32% by weight.

Also the electrode layer may be a silicon-based one. 30 The silicon electrode layer may be either polycrystalline silicon (p-Si) or amorphous silicon (a-Si), or even single crystal silicon if desired.

In addition to silicon as the main component, the 35 electrode layer is doped with an impurity for imparting electric conductivity. Any dopant may be used as the impurity as long as it can impart the desired conductivity.

Use may be made of dopants commonly used in the silicon semiconductor art. Exemplary dopants are B, P, As, Sb, Al and the like. Of these, B, P, As, Sb and Al are especially preferred. The preferred dopant concentration is about

5 0.001 to 5 at%.

In forming the electrode layer from these materials, any of conventional methods such as evaporation, sputtering, CVD, sol-gel and printing/firing methods may be used. Particularly when a structure in which a thick film having an electrode built therein is formed on a substrate is fabricated, the same method as used for the dielectric thick film is preferred.

The electrode layer should preferably have a resistivity of up to  $1 \Omega \cdot \text{cm}$ , especially about 0.003 to 0.1

15  $\Omega \cdot \text{cm}$  in order to apply an effective electric field across the light emitting layer. The preferred thickness of the electrode layer is about 50 to 10,000 nm, more preferably about 100 to 5,000 nm, especially about 100 to 3,000 nm, though it depends on the identity of electrode material.

20 The dielectric thick-film materials used as the first insulating layer include well-known dielectric thick-film materials. Those materials having a relatively high permittivity, dielectric strength and insulation resistance are preferred.

25 For example, such materials as lead titanate, lead niobate and barium titanate base materials may be used as the main component. Barium titanate ( $\text{BaTiO}_3$ ) is especially preferred in relation to the substrate.

The dielectric layer may further contain as an  
30 auxiliary component one or more oxides selected from among manganese oxide ( $\text{MnO}$ ), magnesium oxide ( $\text{MgO}$ ), tungsten oxide ( $\text{WO}_3$ ), calcium oxide ( $\text{CaO}$ ), zirconium oxide ( $\text{ZrO}_2$ ), niobium oxide ( $\text{Nb}_2\text{O}_5$ ) and cobalt oxide ( $\text{Co}_2\text{O}_3$ ) or the oxide or oxides of one or more elements selected from among rare  
35 earth elements Sc, Y, La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm, Yb and Lu. The auxiliary component is

preferably contained in an amount of up to 50 mol%, more preferably 0.004 to 40 mol%, and even more preferably 0.01 to 30 mol% based on the main component, especially BaTiO<sub>3</sub>.

Also, the dielectric layer may further contain a  
5 vitreous component of silicon oxide (SiO<sub>2</sub>), preferably in  
an amount of up to 2% by weight, especially 0.05 to 0.5% by  
weight. The inclusion of the vitreous component leads to  
an improvement in sinterability.

Moreover, any one or a mixture of two or more of the  
10 following materials may be used.

(A) Perovskite type materials: lead family perovskite  
compounds such as PbTiO<sub>3</sub>, rare earth-containing lead  
titinate, PZT (lead zircon titanate) and PLZT (lead  
lanthanum zircon titanate); NaNbO<sub>3</sub>, KNbO<sub>3</sub>, NaTaO<sub>3</sub>, KTaO<sub>3</sub>,  
15 CaTiO<sub>3</sub>, SrTiO<sub>3</sub>, BaTiO<sub>3</sub>, BaZrO<sub>3</sub>, CaZrO<sub>3</sub>, SrZrO<sub>3</sub>, CdZrO<sub>3</sub>,  
CdHfO<sub>3</sub>, SrSnO<sub>3</sub>, LaAlO<sub>3</sub>, BiFeO<sub>3</sub>, and bismuth family  
perovskite compounds. Included are simple perovskite  
compounds as above, complex perovskite compounds containing  
three or more metal elements, perovskite-type complex and  
20 layer compounds.

(B) Tungsten bronze type materials: tungsten bronze  
type oxides such as lead niobate, SBN (strontium barium  
niobate), PBN (lead barium niobate), PbNb<sub>2</sub>O<sub>6</sub>, PbTa<sub>2</sub>O<sub>6</sub>,  
PbNb<sub>4</sub>O<sub>11</sub>, Ba<sub>2</sub>KNb<sub>5</sub>O<sub>15</sub>, Ba<sub>2</sub>LiNb<sub>5</sub>O<sub>15</sub>, Ba<sub>2</sub>AgNb<sub>5</sub>O<sub>15</sub>, Ba<sub>2</sub>RbNb<sub>5</sub>O<sub>15</sub>,  
25 SrNb<sub>2</sub>O<sub>6</sub>, Sr<sub>2</sub>NaNb<sub>5</sub>O<sub>15</sub>, Sr<sub>2</sub>LiNb<sub>5</sub>O<sub>15</sub>, Sr<sub>2</sub>KNb<sub>5</sub>O<sub>15</sub>, Sr<sub>2</sub>RbNb<sub>5</sub>O<sub>15</sub>,  
Ba<sub>3</sub>Nb<sub>10</sub>O<sub>28</sub>, Bi<sub>3</sub>Nd<sub>17</sub>O<sub>47</sub>, K<sub>3</sub>Li<sub>2</sub>Nb<sub>5</sub>O<sub>15</sub>, K<sub>2</sub>RNb<sub>5</sub>O<sub>15</sub> (wherein R is Y,  
La, Ce, Pr, Nd, Sm, Eu, Gd, Tb, Dy or Ho), K<sub>2</sub>BiNb<sub>5</sub>O<sub>15</sub>,  
Sr<sub>2</sub>TlNb<sub>5</sub>O<sub>15</sub>, Ba<sub>2</sub>NaNb<sub>5</sub>O<sub>15</sub>, and Ba<sub>2</sub>KNb<sub>5</sub>O<sub>15</sub>.

(C) YMnO<sub>3</sub> type materials: oxides containing a rare  
30 earth element (inclusive of Sc and Y), Mn and O and having  
a hexagonal YMnO<sub>3</sub> structure. Exemplary are YMnO<sub>3</sub> and  
HoMnO<sub>3</sub>.

Most of these materials are ferroelectric. These  
materials are described in further detail.

35 Of (A) perovskite type materials, BaTiO<sub>3</sub> and Sr  
family perovskite compounds are generally represented by

the chemical formula  $\text{ABO}_3$ , wherein A and B each are a cation. Preferably, A is at least one element selected from among Ca, Ba, Sr, Pb, K, Na, Li, La and Cd, and B is at least one element selected from among Ti, Zr, Ta and Nb.

5       The ratio A/B in such perovskite type compounds is preferably between 0.8 and 1.3, and more preferably between 0.9 and 1.2.

10      Ratios of A/B in the above range ensure the insulation of dielectrics and improve the crystallinity thereof, improving the dielectric or ferroelectric characteristics thereof. By contrast, at A/B ratios below 0.8, the crystallinity improving effect is not expectable. At A/B ratios beyond 1.3, it is difficult to form homogeneous thin films.

15      The desired A/B is accomplished by controlling film depositing conditions. The proportion of O in  $\text{ABO}_3$  is not limited to 3. Some perovskite materials form a stable perovskite structure when they are in short or excess of oxygen. In  $\text{ABO}_x$ , the value of x is generally from about 2.7 to about 3.3. It is understood that the A/B ratio can be determined by x-ray fluorescence analysis.

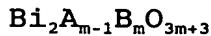
20      The  $\text{ABO}_3$  type perovskite compound used herein may be any of  $\text{A}^{1+}\text{B}^{5+}\text{O}_3$ ,  $\text{A}^{2+}\text{B}^{4+}\text{O}_3$ ,  $\text{A}^{3+}\text{B}^{3+}\text{O}_3$ ,  $\text{A}_x\text{BO}_3$ ,  $\text{A}(\text{B}'_{0.67}\text{B}''_{0.33})\text{O}_3$ ,  $\text{A}(\text{B}'_{0.33}\text{B}''_{0.67})\text{O}_3$ ,  $\text{A}(\text{B}^{+3}_{0.5}\text{B}^{+5}_{0.5})\text{O}_3$ ,  $\text{A}(\text{B}^{2+}_{0.5}\text{B}^{6+}_{0.5})\text{O}_3$ ,  $\text{A}(\text{B}^{1+}_{0.5}\text{B}^{7+}_{0.5})\text{O}_3$ ,  $25 \text{A}^{3+}(\text{B}^{2+}_{0.5}\text{B}^{4+}_{0.5})\text{O}_3$ ,  $\text{A}(\text{B}^{1+}_{0.25}\text{B}^{5+}_{0.75})\text{O}_3$ ,  $\text{A}(\text{B}^{3+}_{0.5}\text{B}^{4+}_{0.5})\text{O}_{2.75}$ , and  $\text{A}(\text{B}^{2+}_{0.5}\text{B}^{5+}_{0.5})\text{O}_{2.75}$ .

30      More illustrative are lead family perovskite compounds such as PZT and PLZT,  $\text{NaNbO}_3$ ,  $\text{KNbO}_3$ ,  $\text{NaTaO}_3$ ,  $\text{KTaO}_3$ ,  $\text{CaTiO}_3$ ,  $\text{SrTiO}_3$ ,  $\text{BaTiO}_3$ ,  $\text{BaZrO}_3$ ,  $\text{CaZrO}_3$ ,  $\text{SrZrO}_3$ ,  $\text{CdHfO}_3$ ,  $\text{CdZrO}_3$ ,  $\text{SrSnO}_3$ ,  $\text{LaAlO}_3$ ,  $\text{BiFeO}_3$ , bismuth family perovskite compounds, and solid solutions thereof.

35      It is to be noted that PZT is a solid solution of  $\text{PbZrO}_3$ - $\text{PbTiO}_3$  system. PLZT is a compound of PZT doped with La and has the formula:  $(\text{Pb}_{0.89-0.91}\text{La}_{0.11-0.09})(\text{Zr}_{0.65}\text{Ti}_{0.35})\text{O}_3$  when represented according to the  $\text{ABO}_3$ .

      Of the layer perovskite compounds, bismuth family

layer compounds are generally represented by the formula:



wherein m is an integer of 1 to 5, A is selected from among Bi, Ca, Sr, Ba, Pb, Na, K and rare earth elements (inclusive of Sc and Y), and B is Ti, Ta or Nb.

Illustrative are  $\text{Bi}_4\text{Ti}_3\text{O}_{12}$ ,  $\text{SrBi}_2\text{Ta}_2\text{O}_9$ , and  $\text{SrBi}_2\text{Nb}_2\text{O}_9$ . Any of these compounds or a solid solution thereof may be used in the practice of the invention.

The preferred perovskite type compounds used herein are those having a high permittivity, for example,  $\text{NaNbO}_3$ ,  $\text{KNbO}_3$ ,  $\text{KTaO}_3$ ,  $\text{CdHfO}_3$ ,  $\text{CdZrO}_3$ ,  $\text{BiFeO}_3$  and bismuth family perovskite compounds, with  $\text{CdHfO}_3$  being more preferred.

(B) The tungsten bronze type materials are preferably those tungsten bronze type materials described in the collection of ferroelectric materials by Landoit-Borenstein, Vol. 16. The tungsten bronze type materials generally have the chemical formula:  $\text{A}_y\text{B}_5\text{O}_{15}$  wherein A and B each are a cation. Preferably, A is one or more elements of Mg, Ca, Ba, Sr, Pb, K, Na, Li, Rb, Tl, Bi, rare earth elements and Cd, and B is one or more elements selected from Ti, Zr, Ta, Nb, Mo, W, Fe and Ni.

The ratio O/B in these tungsten bronze type materials is not limited to 15/5. Some tungsten bronze type materials form a stable tungsten bronze structure when they are in short or excess of oxygen. The ratio O/B is generally between about 2.6 and about 3.4.

Illustrative examples include tungsten bronze type oxides, such as  $(\text{Ba}, \text{Pb})\text{Nb}_2\text{O}_6$ ,  $\text{PbNb}_2\text{O}_6$ ,  $\text{PbTa}_2\text{O}_6$ ,  $\text{PbNb}_4\text{O}_{11}$ ,  $\text{PbNb}_2\text{O}_6$ , SBN (strontium barium niobate),  $\text{Ba}_2\text{KNb}_5\text{O}_{15}$ ,  $\text{Ba}_2\text{LiNb}_5\text{O}_{15}$ ,  $\text{Ba}_2\text{AgNb}_5\text{O}_{15}$ ,  $\text{Ba}_2\text{RbNb}_5\text{O}_{15}$ ,  $\text{SrNb}_2\text{O}_6$ ,  $\text{BaNb}_2\text{O}_6$ ,  $\text{Sr}_2\text{NaNb}_5\text{O}_{15}$ ,  $\text{Sr}_2\text{LiNb}_5\text{O}_{15}$ ,  $\text{Sr}_2\text{KNb}_5\text{O}_{15}$ ,  $\text{Sr}_2\text{RbNb}_5\text{O}_{15}$ ,  $\text{Ba}_3\text{Nb}_{10}\text{O}_{28}$ ,  $\text{Bi}_3\text{Nd}_{17}\text{O}_{47}$ ,  $\text{K}_3\text{Li}_2\text{Nb}_5\text{O}_{15}$ ,  $\text{K}_2\text{RNb}_5\text{O}_{15}$  (wherein R is Y, La, Ce, Pr, Nd, Sm, Eu, Gd, Tb, Dy or Ho),  $\text{K}_2\text{BiNb}_5\text{O}_{15}$ ,  $\text{Sr}_2\text{TlNb}_5\text{O}_{15}$ ,  $\text{Ba}_2\text{NaNb}_5\text{O}_{15}$ , and  $\text{Ba}_2\text{KNb}_5\text{O}_{15}$ , and solid solutions thereof. Preferred among others are SBN (( $\text{Ba}, \text{Sr}$ ) $\text{Nb}_2\text{O}_6$ ),  $\text{Ba}_2\text{KNb}_5\text{O}_{15}$ ,  $\text{Ba}_2\text{LiNb}_5\text{O}_{15}$ ,  $\text{Ba}_2\text{AgNb}_5\text{O}_{15}$ ,  $\text{Sr}_2\text{NaNb}_5\text{O}_{15}$ ,  $\text{Sr}_2\text{LiNb}_5\text{O}_{15}$ , and  $\text{Sr}_2\text{KNb}_5\text{O}_{15}$ .

(C) The YMnO<sub>3</sub> type materials have the chemical formula: RMnO<sub>3</sub>, wherein R is preferably at least one rare earth element (inclusive of Sc and Y). The ratio R/Mn in the YMnO<sub>3</sub> type materials is preferably between 0.8 and 1.2, and more preferably between 0.9 and 1.1. Ratios of R/Mn in this range ensure the insulation of dielectrics and improve the crystallinity thereof, improving the ferroelectric characteristics thereof. By contrast, R/Mn ratios below 0.8 or above 1.2 tend to lower crystallinity. Especially at R/Mn ratios beyond 1.2, materials are likely to be paraelectric rather than ferroelectric and sometimes cannot be applied to devices utilizing polarization. The desired R/Mn is accomplished by controlling film depositing conditions. It is understood that the R/Mn ratio can be determined by x-ray fluorescence analysis.

The preferred YMnO<sub>3</sub> type materials used herein have a hexagonal crystal structure. The existing YMnO<sub>3</sub> type materials include those having a hexagonal crystal structure and those having a rhombic crystal structure. To achieve the phase transition effect, hexagonal crystal materials are preferred. Illustrative are materials having a substantial composition of YMnO<sub>3</sub>, HoMnO<sub>3</sub>, ErMnO<sub>3</sub>, YbMnO<sub>3</sub>, TmMnO<sub>3</sub> or LuMnO<sub>3</sub>, or solid solutions thereof.

The dielectric layer thick-film preferably has a resistivity of at least about 10<sup>8</sup> Ω·cm, especially about 10<sup>10</sup> to 10<sup>18</sup> Ω·cm. A material having a relatively high permittivity as well is preferred. The permittivity ε is preferably about 100 to 10,000. The film thickness is preferably 5 to 50 μm, and more preferably 10 to 30 μm.

Any desired method may be used in forming the dielectric layer thick-film. A method capable of easily forming a film of 10 to 50 μm thick is recommended, with the sol-gel and printing/firing methods being preferred.

When the printing/firing method is used, a material having a properly selected particle size is mixed with a

binder to form a paste having an appropriate viscosity. The paste is applied onto a substrate by a screen printing technique and dried. The green sheet is fired at a suitable temperature, yielding a thick film.

5 If the thick film thus obtained has asperities or holes as large as 1  $\mu\text{m}$  or more, it is preferred in some embodiments to improve the surface flatness or smoothness by polishing the film or forming a smoothing layer thereon.

In the inorganic electroluminescent (EL) device, the  
10 materials used in its light emitting layer includes ZnS and Mn/CdSSe as the red light emitting material, ZnS:TbOF and ZnS:Tb as the green light emitting material, and SrS:Ce, (SrS:Ce/ZnS)<sub>n</sub>, CaGa<sub>2</sub>S<sub>4</sub>:Ce, and SrGa<sub>2</sub>S<sub>4</sub>:Ce as the blue light emitting material. Multilayer films of SrS:Ce/ZnS:Mn and  
15 the like are known as the material capable of emitting white light.

In the practice of the invention, the materials used in the fluorescent thin film of the EL device preferably include Group II-sulfur compounds, Group II-Group III-sulfur compounds and rare earth sulfides, and more illustratively, II-S compounds as typified by SrS, II-III<sub>2</sub>-S<sub>4</sub> compounds (wherein II = Zn, Cd, Ca, Mg, Be, Sr, Ba or rare earth and III = B, Al, Ga, In or Tl) as typified by SrGa<sub>2</sub>S<sub>4</sub>, and rare earth sulfides such as Y<sub>2</sub>S<sub>3</sub>, and mixed  
25 crystals or mixed compounds obtained by combining plural components using these compounds.

The compositional ratio of these compounds does not strictly take the above-described value, but has a certain solid solution limit with respect to each element.  
30 Therefore, a compositional ratio within that range is acceptable.

In general, the EL phosphor thin-film is formed of a matrix material to which a luminescence center is added. Any luminescence center selected from well-known transition  
35 metals and rare earth elements may be added in a conventional quantity. For example, a rare earth element

such as Ce or Eu or Cr, Fe, Co, Ni, Cu, Bi, Ag or the like in metallic or sulfide form is added to a raw material. Since the addition quantity varies with the raw material and the thin film to be formed, the composition of the raw 5 material is adjusted so that the thin film may have an ordinary addition quantity.

Any of well-known techniques such as evaporation, sputtering, CVD, sol-gel and printing/firing techniques may be used in forming an EL phosphor thin-film from these 10 materials.

The thickness of the light emitting layer is not critical. Too large a thickness causes to increase the drive voltage whereas too small a thickness leads to a decline of emission efficiency. Illustratively, the 15 thickness is preferably about 100 to 1,000 nm, and especially about 150 to 700 nm, though it depends on the identity of phosphor material.

To obtain a sulfide phosphor thin-film having a high luminance, a sulfide phosphor of the desired composition is 20 preferably formed at a high temperature in excess of 600°C or annealed at a high temperature in excess of 600°C, if desired. In particular, to obtain a blue phosphor having a high luminance, a high-temperature process is effective. The dielectric thick-film for inorganic EL devices 25 according to the invention can withstand such high-temperature process.

The inorganic EL device preferably includes a thin-film insulating layer (or second insulating layer) between the electrode layer and the phosphor thin-film (or light 30 emitting layer). The materials of which the thin-film insulating layer is made include silicon oxide ( $\text{SiO}_2$ ), silicon nitride ( $\text{Si}_3\text{N}_4$ ), tantalum oxide ( $\text{Ta}_2\text{O}_5$ ), strontium titanate ( $\text{SrTiO}_3$ ), yttrium oxide ( $\text{Y}_2\text{O}_3$ ), barium titanate ( $\text{BaTiO}_3$ ), lead titanate ( $\text{PbTiO}_3$ ), PZT, zirconia ( $\text{ZrO}_2$ ), 35 silicon oxynitride ( $\text{SiON}$ ), alumina ( $\text{Al}_2\text{O}_3$ ), lead niobate, PMN-PT base materials and multilayer or mixed thin-films

thereof. Any of well-known techniques such as evaporation, sputtering, CVD, sol-gel and printing/firing techniques may be used in forming the insulating layer from these materials. The insulating layer thus formed preferably has 5 a thickness of about 50 to 1,000 nm, and especially about 100 to 500 nm.

Once the thin-film insulating layer is formed, another thin-film insulating layer may be formed in a duplex configuration using another material, if desired.

10 Further, an electrode layer (or second electrode) is preferably formed on the thin-film insulating layer. The material of the electrode layer is preferably selected from the electrode materials described above.

15 Using the composite substrate of the invention, an EL device can be constructed in this way. Since the phosphor thin-film can be formed by the high-temperature process, the performance of a blue phosphor which is short of luminance in the prior art can be significantly improved, and hence, a full-color EL display can be implemented.

20 Further, since an insulating thick-film having a high density and free of cracks can be formed according to the invention, the EL device is less prone to breakdown and outstandingly increased in stability as compared with conventional thin-film dual insulating structure, achieving 25 a higher luminance and a lower voltage.

The composite substrate is preferably prepared by a conventional thick-film laminating technique.

Specifically, onto a substrate of magnesia ( $MgO$ ), steatite ( $MgO \cdot SiO_2$ ) or forsterite ( $2MgO \cdot SiO_2$ ), a paste using a 30 conductive powder such as Pd or Pt as a source is printed in a pattern by a screen printing technique or the like. Further, a thick film is formed thereon using a dielectric paste prepared employing a powdery dielectric material as a source. Alternatively, the dielectric paste is cast to 35 form a green sheet, which is placed and press bonded onto the electrode. It is also possible to print an electrode

on a green sheet of dielectric, which is press bonded to a stress relief layer on the substrate.

In a further alternative, a green laminate sheet consisting of a stress relief layer, electrode and 5 dielectric is separately formed and press bonded to the substrate. The stress relief layer having a graded composition can be formed by successively stacking layers of varying composition.

The structure thus constructed is fired at a 10 temperature of 1,000°C to less than 1,600°C, preferably 1,200°C to 1,500°C, and more preferably 1,300°C to 1,450°C.

#### EXAMPLE

Examples are given below for illustrating the 15 composite substrate and EL device according to the invention.

##### Example 1

On a substrate shown in Table 1, a paste based on Pd 20 powder was printed in a stripe pattern having a width of 1.6 mm and a gap of 1.5 mm as an electrode and dried for several minutes at 1,100°C.

Separately, MnO, MgO, Y<sub>2</sub>O<sub>3</sub>, V<sub>2</sub>O<sub>5</sub> or (Ba,Ca)SiO<sub>3</sub> was added to BaTiO<sub>3</sub> powder in a predetermined concentration and 25 mixed in water. The mixed powder was dried and admixed with a binder to form a dielectric paste. The dielectric paste thus obtained was printed onto the electrode pattern-printed substrate to a thickness of 30 μm, dried, and fired in air at 1,200°C for 2 hours. The dielectric layer as 30 fired was 10 μm thick.

To measure the electric characteristics of the dielectric layer, a sample was separately prepared by printing a stripe pattern of Pd electrode having a width of 1.5 mm and a gap of 1.5 mm so as to extend perpendicular to 35 the underlying electrode pattern after drying of the

dielectric paste, drying and firing in the above-mentioned temperature profile. An EL device was constructed by sputtering a Mn-doped ZnS target, with the composite substrate heated at 250°C, to form a ZnS phosphor thin film

5 of 0.7  $\mu\text{m}$  thick, followed by heat treatment in vacuum for 10 minutes. Then a  $\text{Si}_3\text{N}_4$  thin film as the second insulating layer and an ITO thin film as the second electrode were successively formed by sputtering, completing the EL device.

10 The luminescent characteristics of the EL device were determined by extending electrodes from the printed/fired electrode and the ITO transparent electrode of the cell structure obtained above and applying an electric field at a frequency of 1 kHz and a pulse width of 50  $\mu\text{s}$ .

15 Table 1 shows the electrical characteristics of the dielectric layers of the composite substrates prepared as above and the luminescent characteristics of the EL devices fabricated using the composite substrates.

Table 1

No.	Substrate material	Dielectric layer	Firing temperature (°C)	Dielectric layer thickness (μm)	Relative permittivity
1	MgO	BaTiO <sub>3</sub> thick film	1200	17	2060
2	MgO	BaTiO <sub>3</sub> thick film	—	1270	1660
3	MgO	BaTiO <sub>3</sub> thick film	—	1340	2300
4	MgO	BaTiO <sub>3</sub> thick film	—	1410	7510
5	MgO	BaTiO <sub>3</sub> thick film	—	1340	2300
6	MgO	BaTiO <sub>3</sub> thick film	—	1340	2300
7	MgO	BaTiO <sub>3</sub> thick film	—	1340	2300
8	MgO-SiO <sub>2</sub>	BaTiO <sub>3</sub> thick film	—	1340	1650
9	2MgO-SiO <sub>2</sub>	BaTiO <sub>3</sub> thick film	—	1340	1570
Com. 1	blue sheet glass	Y <sub>2</sub> O <sub>3</sub> thin film	—	—	0.6
Com. 2	blue sheet glass	Si <sub>3</sub> N <sub>4</sub> thin film	—	—	12
					8

Com. : Comparative example

Table 1 (cont'd)

No.	tan $\delta$ (%)	Dielectric strength (V/ $\mu$ m)	Heat treating temperature of phosphor layer ( $^{\circ}$ C)	Emission start voltage (V)	Emission at 210 V (cd/m $^2$ )
1	2.2	19	600	120	1500
2	2.6	20	600	135	1300
3	0.8	40	600	138	1250
4	0.8	9	600	140	1250
5	0.8	40	800	98	1270
6	0.8	40	900	99	1250
7	0.8	40	1000	95	1200
8	1.2	35	600	130	1020
9	1.7	30	600	130	1000
Com. 1	1.1	370	—	186	150
Com. 2	1.0	720	—	192	60

Com.: Comparative example

As is evident from Table 1, the inventive samples in which the coefficient of thermal expansion of substrates is adjusted optimum to permit use of a thick film of high permittivity material have a low emission start voltage as compared with prior art devices, and provide a higher emission luminance when the same voltage is applied. Elevating the heat treating temperature is effective for further reducing the emission start voltage.

10

#### BENEFITS OF THE INVENTION

According to the invention, there are provided a composite substrate which suppresses reaction of a substrate with a dielectric layer that can otherwise cause degradation of the dielectric layer and which can be sintered at high temperature while minimizing the occurrence of cracks in the dielectric layer, and an EL device using the composite substrate.